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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

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Sheet 1 of 1

Application Number	Based on PCT/GB2004/000161
Confirmation Number	Unknown
Filing Date	July 18, 2005
First Named Inventor	Henning SIRRINGHAUS
Art Unit	Unknown
Examiner Name	Unknown
Attorney Docket Number	Q89250

**U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code <sup>3</sup> (if known)		
		US 2002/119584	A1	08-29-2002	Gregg Duthaler, et al.
		US			
		US			
		US			
		US			

**FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation <sup>4</sup>
		Country Code <sup>2</sup>	Number <sup>2</sup>	Kind Code <sup>3</sup> (if known)			
		WO	01/46987	A	06-28-2001	PLASTIC LOGIC LTD	

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issu number(s), publisher, city, and/or country where published.	Translation <sup>4</sup>
		KAWASE, T. et al., "All-Polymer Thin Film Transistors Fabricated by Inkjet Printing", Proceedings of the SPIE, SPIE, Bellingham, VA, US Vol. 4466, July 29, 2001, Pages 80-88, XP008006102, ISSN: 0277-786X	
		CHABINYC MICHAEL L. et al., "Organic Polymeric Thin-film Transistors Fabricated by Selective Dewatering", Applied Physics Letters, American Institute of Physics, New York, US, Vol. 81, No. 22, November 25, 2002, 4260-4262, XP012032662, ISSN: 0003-6951	
		ZHANG, J. et al., Investigation of Using Contact and Non-contact Printing Technologies For Organic Transistor Fabrication, Material Research Society Symposium Proceedings, Materials Research Society, Pittsburgh, PA, US, Vol. 725, April 1, 2002, Pages 155-160, XP008020720, ISSN: 0272-9172	
		PEDE, D., et al., Microfabrication of Conducting Polymer Devices by Ink-jet Stereolithography", Materials Science and Engineering C, Elsevier Science S.A, CH, Vol. C05, No. 3/4, February 1998, pages 289-291, XP000828177, ISSN: 0928-4931	

Examiner Signature

/Tuan Nguyen/ (05/20/2008)

Date Considered

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<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kind Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov), MPEP 901.04 or in the comment box of this document. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to indicate here if English language Translation is attached.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /TN/